IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Yan, et al.

Attorney Docket: 2003 P 51686 US

Filed:

Herewith

Examiner:

TBD

Serial No.:

TBD

Art Unit:

TBD

For:

Method of Forming Shallow Trench Isolation Using Deep Trench Isolation

Mail Stop: Patent Application Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

The Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form PTO/SB/08A that may be considered material to the examination of the above identified application.

No fee is due at this time, as this Information Disclosure Statement is being filed concurrently with the patent application.

Respectfully submitted,

Attorney for Applicants

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Substitute for form 1449/PTO				Complete if Known		
				Application Number	TBD	
				Filing Date	Herewith	
INFORMATION DISCLOSURE				First Named Inventor	Yan	
STATEMENT BY APPLICANT (use as many sheets as necessary)				Art Unit	TBD	
			sary) 	Examiner Name	TBD	
Sheet	1	of	1	Attorney Docket Number	2003 P 51686 US	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.1	Document Number Number - Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US-4,994,406	02/19/1991	Vasquez, et al.	
	<u> </u>	US-6,297,127 B1	10/02/2001	Chen, et al.	
		US-			

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ - Number ⁴ - Kind Code ⁵ (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
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Examiner	Date
Signature	Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. Applicant's unique citation designation number (optional). See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. Kind of document by the appropriate symbols as indicated on the document will be Standard ST. 16 if possible. Applicant is to place a check mark here if English language Translation is attached.

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